



ELECTRONIC COPY

LG787660629
Report verification at igi.org



March 31, 2026
IGI Report Number **LG787660629**
Description **LABORATORY GROWN DIAMOND**
Shape and Cutting Style **CUT CORNERED
RECTANGULAR MODIFIED
BRILLIANT**
Measurements **10.51 X 6.94 X 4.53 MM**
GRADING RESULTS
Carat Weight **2.93 CARATS**
Color Grade **G**
Clarity Grade **VS 1**
Cut Grade **EXCELLENT**

LABORATORY GROWN DIAMOND REPORT

March 31, 2026
IGI Report Number **LG787660629**
Description **LABORATORY GROWN DIAMOND**
Shape and Cutting Style **CUT CORNERED RECTANGULAR
MODIFIED BRILLIANT**
Measurements **10.51 X 6.94 X 4.53 MM**

GRADING RESULTS

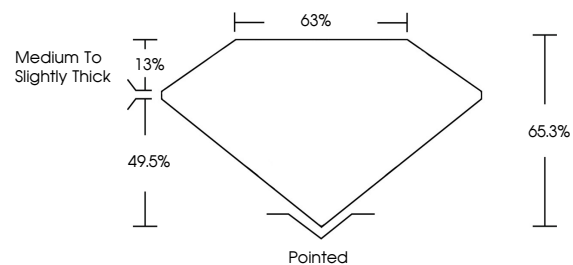
Carat Weight **2.93 CARATS**
Color Grade **G**
Clarity Grade **VS 1**
Cut Grade **EXCELLENT**

ADDITIONAL GRADING INFORMATION

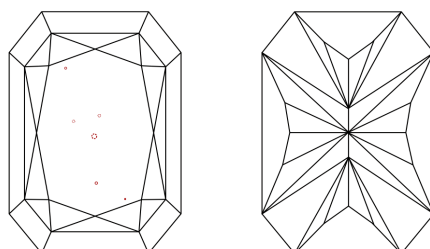
Polish **EXCELLENT**
Symmetry **EXCELLENT**
Fluorescence **NONE**
Inscription(s) **IGI LG787660629**

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa

PROPORTIONS



CLARITY CHARACTERISTICS



KEY TO SYMBOLS

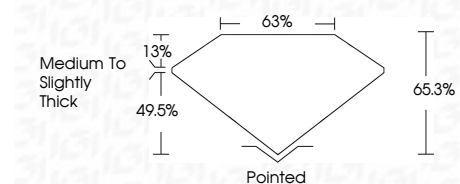
Red symbols indicate internal characteristics.
Green symbols indicate external characteristics.

COLOR

D E F G H I J Faint Very Light Light

CLARITY

FL	IF	VS ¹⁻²	VS ¹⁻²	SI ¹⁻²	I ¹⁻³
Flawless	Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included



ADDITIONAL GRADING INFORMATION

Polish **EXCELLENT**
Symmetry **EXCELLENT**
Fluorescence **NONE**
Inscription(s) **IGI LG787660629**
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CUT CORNERED RECT. MODIFIED BRILLIANT
10.51 X 6.94 X 4.53 MM
Carat Weight **2.93 CARATS**
Color Grade **G**
Clarity Grade **VS 1**
Cut Grade **EXCELLENT**
Depth **65.3%**
Table **63%**
Girdle **Medium To Slightly Thick**
Culet **Pointed**
Polish **EXCELLENT**
Symmetry **EXCELLENT**
Fluorescence **NONE**
Inscriptions(s) **IGI LG787660629**
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa